

Substitute Form PTO-1449 (Modified)  <b>Information Disclosure Statement by Applicant</b> (Use several sheets if necessary)  (37 CFR §1.98(b))      IDS filed 8/25/2003	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 10559-839001/Intel P16714	Application No. <del>New Application</del> 10/648627
	Applicant Manish Chandhok		
	Filing Date	Group Art Unit Unknown 2877 10/13/04	

**U.S. Patent Documents**


Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
LD	AA	6,481,003 B1	11/12/2002	Maeda			
LD	AB	6,567,155 B1	5/20/2003	Chandhok et al.			
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

**Foreign Patent Documents or Published Foreign Patent Applications**

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							

**Other Documents (include Author, Title, Date, and Place of Publication)**

Examiner Initial	Desig. ID	Document
LD	AQ	John E. Bjorkholm, "EUV Lithography—The Successor to Optical Lithography?", Intel Technology Journal Q3'98 (John.Bjorkholm@intel.com)
	AR	
	AS	
	AT	

Examiner Signature 	Date Considered 10/13/04
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	